



Image RCG/1765

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date January 14, 2004

In re the Application of

Makoto IIDA et al.

Group Art Unit: 1765

Application No.: 09/869,912

Examiner: R. Kunemund

Filed: July 9, 2001

Docket No.: 110051

For: SILICON SINGLE CRYSTAL WAFER, METHOD FOR PRODUCING THE SAME AND SOI WAFER

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired October 14, 2003, an extension of time for a period of 3 months is hereby requested. Attached hereto is our Check No. 150130 in the amount of \$950.00 (a one-month extension fee of \$110.00 having been paid on November 3, 2003 by our check number 147908) in payment for:

- _____ Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
- _____ Extension fee for response within second month pursuant to §1.136(a) (\$420.00)
- X Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

01/15/2004 JBALIMAN 00000064 09869912
01 FC:1253 950.00 OP

Respectfully submitted,

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DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
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Deposit Account No. 15-0461